



Appl. No. 10/685,588

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : **10/685,588**
Applicants : **Chia-Lin Hsu et al.**
Filed : **October 16, 2003**
Title : **Method for Preventing Edge Peeling Defect**
TC/A.U. : **2891**
Examiner : **EVERHART, CARIDAD**
Docket No. : **025796-00009**
Response Dte : **August 26, 2005**

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This paper is in response to the Official Action dated June 27, 2005. Applicants respectfully request that Examiner reconsiders the application according to the following remarks.

Please amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.